

## Application Data Sheet

### **Application Information**

|                                  |  |
|----------------------------------|--|
| Application Type::               | Regular  |
| Subject Matter::                 | Utility  |
| Suggested Group Art Unit::       | N/A  |
| CD-ROM or CD-R?::                | None   |
| Sequence submission?::           | None   |
| Computer Readable Form (CRF)?::  | No   |
| Title::                          | METHOD FOR N+ DOPING OF<br>AMORPHOUS SILICON AND<br>POLYSILICON ELECTRODES IN DEEP<br>TRENCHES |
| Attorney Docket Number::         | INTECH 3.0-104   |
| Request for Early Publication?:: | No   |
| Request for Non-Publication?::   | No   |
| Suggested Drawing Figure::       | 1  |
| Total Drawing Sheets::           | 6  |
| Small Entity?::                  | No   |
| Petition included?::             | No   |
| Secrecy Order in Parent Appl.?:: | No   |

### **Applicant Information**

|                               |                 |
|-------------------------------|-----------------|
| Applicant Authority Type::    | Inventor        |
| Primary Citizenship Country:: | Germany         |
| Status::                      | Full Capacity   |
| Given Name::                  | Moritz          |
| Family Name::                 | Haupt           |
| City of Residence::           | Dresden         |
| Country of Residence::        | Germany         |
| Street of mailing address::   | Am Schulholz 10 |
| City of mailing address::     | Dresden         |

Country of mailing address:: Germany  
Postal or Zip Code of mailing address:: D-01109

**Correspondence Information**

Correspondence Customer Number:: 000530

**Representative Information**

Representative Customer Number:: 000530

**Assignee Information**

Assignee name:: Infineon Technologies North America Corp.  
Street of mailing address:: 1730 North First Street  
City of mailing address:: San Jose  
State or Province of mailing address:: CA  
Postal or Zip Code of mailing address:: 95112